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FACSIMILE COVER SHEET

To Examiner: HO, TU TU V	Total Pages Sent: 2
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Facsimile Number: (703) 872-9306	Transmission Date: March 1, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Bao, <i>et al.</i>	Docket No.: TSM03-0927
Serial No.: 10/800,510	Art Unit: 2818
Date Filed: March 15, 2004	
TITLE: A Semiconductor Device Having A Second Level Of Metallization Formed Over A First Level With Minimal Damage To The First Level And Method	

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Certification of Facsimile Transmission (1 page)
 Election (1 page)

Respectfully submitted,

Kristy Engeldahl
 Kristy Engeldahl
 Legal Assistant

Confirmation Respectfully Requested

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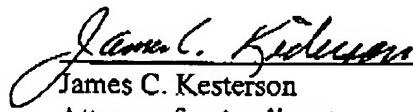
Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

ELECTION

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed on February 1, 2005, Applicant hereby elects Group II: Claims 24-43 for further prosecution in the above patent application

Respectfully submitted,

1 March 2005
Date
James C. Kesterson
Attorney for Applicant
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